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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Complete If Known	
				Application Number	Not Yet Assigned
				Filing Date	Concurrently Herewith
				First Named Inventor	Atsushi Tomozawa, et al.
				Art Unit	N/A
				Examiner Name	Not Yet Assigned
Sheet	1	of	1	Attorney Docket Number	5077-000249/US/NP

U.S. PATENT DOCUMENTS					
Examiner Initials [*]	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
/A.W./	AA*	US-6,194,818	02-27-2001	Sumi et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials [*]	Cite No.	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
/A.W./	BA	JP-2001-223403-A	08-17-2001			✓
/A.W./	BB	JP-11-214763-A	08-06-1999			✓
/A.W./	BC	JP-2000-307163-A	11-02-2000			✓
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/A.W./	BM	JP-2002-363256-A	12-18-2002			✓
/A.W./	BN	JP-2004-079991-A	03-11-2004			✓

- * JP-11-214763-A corresponds to US-6,194,818
- ** JP-3021930 corresponds to JP-04-057242
- *** JP-3481235 corresponds to JP-2002-363256-A

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. * CITE NO.: Those application(s) which are marked with an single asterisk (*) next to the Cite No. are not supplied (under 37 CFR 1.98(a)(3)(iii)) because that application was filed after June 30, 2003 or is available in the IPW. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
/A.W./		Takayama, R., et al.; "Preparation of epitaxial Pb(Zr _x Ti _{1-x})O ₃ thin films and their crystallographic, pyroelectric, and ferroelectric properties", Journal of Applied Physics. U.S.A., The American Institute of Physics, Feb. 15, 1989, Vol. 65, No. 4, pp. 1666-1670	

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Examiner Signature	/Alexander Witkowski/	Date Considered	03/11/2008
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